

INFORMATION DISCLOSURE STATEMENT

Applicant	: Hojo et al.
App. No	: Unknown
Filed	: Herewith
For	: POSITIVE RESIST COMPOSITION AND METHOD OF FORMATION OF RESIST PATTERNS
Examiner	: Unknown
Art Unit	: Unknown

Mail Stop: PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 9 references to be considered by the Examiner. Also enclosed are 6 foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed within three months of the filing date, with an RCE and no fee is required.

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 11 Oct. 2005

By: Daniel E. Altman

Daniel E. Altman
Registration No. 34,115
Attorney of Record
Customer No. 20,995
(949) 760-0404

INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Application No.	Unknown
	Filing Date	Herewith
	First Named Inventor	Hojo, Takuma
	Art Unit	Unknown
(Multiple sheets used when necessary)		Examiner
SHEET 1 OF 1		Attorney Docket No. SHIGA7.029APC

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	1	2002/0111459 A1	08-15-2002	Takeda et al.	
	2	5,558,971	09-24-1996	Urano et al.	
	3	2003/0232273 A1	12-18-2003	Adams et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
	4	JP 11-030865 ✓	02-02-1999	JSR Corp.		Abstract
	5	JP 11-002902 ✓	01-06-1999	JSR Corp.		Abstract
	6	JP 2003-307840 ✓	10-31-2003	Fuji Photo Film Co., Ltd.		Abstract
	7	JP 2002-323768 ✓	11-08-2002	Fuji Photo Film Co., Ltd.		Abstract
	8	JP 2001-316418 ✓	11-13-2001	JSR Corp.		Abstract
	9	JP 2002-139838 ✓	05-17-2002	Fuji Photo Film Co., Ltd.		Abstract

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹

1980520:vr
100705

Examiner Signature	Date Considered
--------------------	-----------------

***Examiner:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

T¹ - Place a check mark in this area when an English language Translation is attached.